

Notice of References Cited	Application/Control No. 10/559,409		Applicant(s)/Patent Under Reexamination VAN DER WIJNGAART ET AL.	
	Examiner Craig Price		Art Unit 3753	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,667,503	06-1972	Farrell et al.	137/625.4
*	B	US-5,058,856	10-1991	Gordon et al.	251/11
*	C	US-5,065,978	11-1991	Albarda et al.	251/129.17
*	D	US-5,325,880	07-1994	Johnson et al.	137/1
*	E	US-5,445,185	08-1995	Watanabe et al.	137/596.17
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*	G	US-6,306,773	10-2001	Ad.ang.s et al.	438/745
*	H	US-7,320,457	01-2008	Heim et al.	251/129.06
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hal Jerman, "Electrically-Activated, Micromachined Diaphragm Valves," Technical Digest IEEE, Sensor and Actuator Workshop, Jun. 1990, pp. 65-69.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.